

October 9, 2024

GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

64% 31.9° Medium 11.5% (Faceted) \checkmark 57.3% 40.3° 42.5%

Pointed

LG657424150

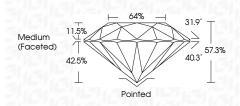
Report verification at igi.org



Sample Image Used

| October 9, 2024 | |
|-------------------------|-----------------------|
| IGI Report Number | LG657424150 |
| Description LAB | ORATORY GROWN DIAMOND |
| Shape and Cutting Style | ROUND BRILLIANT |
| Measurements | 7.52 - 7.54 X 4.31 MM |
| GRADING RESULTS | |
| Carat Weight | 1.50 CARAT |
| Color Grade | E |
| Clarity Grade | VS 1 |
| Cut Grade | VERY GOOD |
| | |

LABORATORY GROWN DIAMOND REPORT



ADDITIONAL GRADING INFORMATION

| Polish | EXCELLENT |
|--|-----------------|
| Symmetry | EXCELLENT |
| Fluorescence | NONE |
| Inscription(s) | (G) LG657424150 |
| Comments: This Laboratory C created by Chemical Vapor process. Type IIa | |



| DDITIONAL GRADING INFOR | CWATION |
|--|------------------|
| olish | EXCELLENT |
| vmmetry | EXCELLENT |
| uorescence | NONE |
| scription(s) | 1671 LG657424150 |
| omments: This Laboratory G reated by Chemical Vapor rocess. roe lia | |

KEY TO SYMBOLS

CLARITY CHARACTERISTICS

PROPORTIONS

Red symbols indicate internal characteristics. Green symbols indicate external characteristics.

| IF | VVS ¹⁻² | VS ¹⁻² | SI 1 - |
|------------|--------------------|-------------------|--------|
| Internally | Very Very | Very | Sligh |
| Flawless | Slightly Included | Slightly Included | |

Faint

Very Light

Light

1.3

Included

COLOR

DEFGHIJ







www.igi.org

IGI Report Number LABORATORY GROWN DIAMOND Description Shape and Cutting Style 7.52 - 7.54 X 4.31 MM Measurements

GRADING RESULTS

Carat Weight 1.50 CARAT Color Grade Е Clarity Grade **VS** 1 Cut Grade VERY GOOD

LG657424150

ROUND BRILLIANT

ADDITIONAL GRADING INFORMATION

| Polish | EXCELLENT | |
|----------------|-----------------|--|
| Symmetry | EXCELLENT | |
| Fluorescence | NONE | |
| Inscription(s) | 151 LG657424150 | |

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa